



◆ A T M I

December 29, 2004

Steven J. Hultquist, Esq. IPTL 1414 Raleigh Road, Ste. 201 Chapel Hill, NC 27517

10715246

RE:

ATMI File No. 645 Malaysia (7495) "CHEMICAL MECHANICAL

PLANARIZATION PAD"

Dear Steven:

In response to your letter dated December 16, 2004, enclosed you will find the fully executed Form 17 with reference to the above subject patent application.

Sincerely,

Danielle Manone

Legal Administrative Assistant

/dm

Enclosure

Patents Form No. 17	For Official Use
PATENTS ACT 1983	Application No.:
APPOINTMENT OF PATENT AGENT	Filing date:
[Regulation 48(2) and 45(3)]	Received on:
To: The Registrar of Patents	
Patent Registration Office Kuala Lumpur S AN 0 5 2005	
RADEMARK CHA	Date of mailing:
Please submit one copy of this Form.	Agent's file reference: SD/PAT/2772002/ZRS/kd
*I/We, the undersigned,	
Name : Advanced Technology Materials, Inc.	
Address : 7 Commerce Drive,	
: Danbury, : Connecticut 06810,	
: United States of America	
Appoint	
Wong Sai Fong (PA 86/0003), Timothy Siaw (PA 92/0032) and/or Zaraihan Shaari (PA 2004/0137) of	
SHEARN DELAMORE & CO. Advocates & Solicitors, Notary Public, Registered Patent Agents, Trademark Agents & Industrial Design Agents	
7th Floor, Wisma Hamzah-Kwong Hing, No.1, Leboh Ampang, 50100 Kuala Lumpur, Malaysia.	
Telephone: 03-20700644 (general); Facsimile: +60-3-20782376; 20785625	
to act as *my/our agent in connection with the following matters(s):	
Chemical Mechanical Planarization Pad	
Ratify all acts done by the agent on *my/our behalf in connection with *this/these matter(s), and request that all notices, requisitions and communications relating thereto be sent to the agent at the said address. Any previous appointment in respect of the same matter(s) is revoked.	
SIGNATURE: Del PS-CG	Date: .12/29/04
Name:Daniel.1PSharkey	
Designation:Chief · Pianancial · Officer ····	

^{*} Delete whichever does not apply NO NOTARISATION OR LEGALISATION REQUIRED.